

Beam Diagnostics



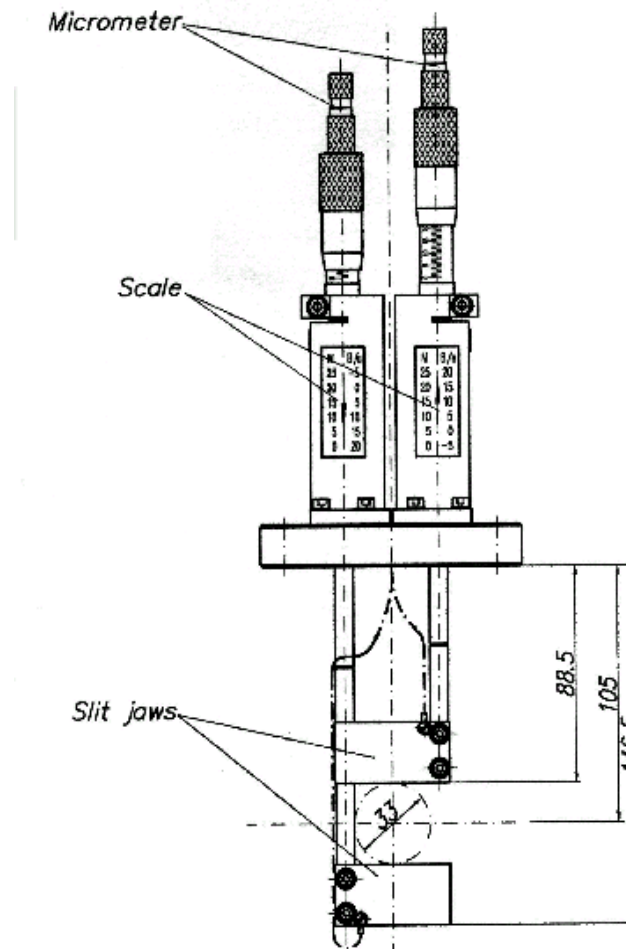
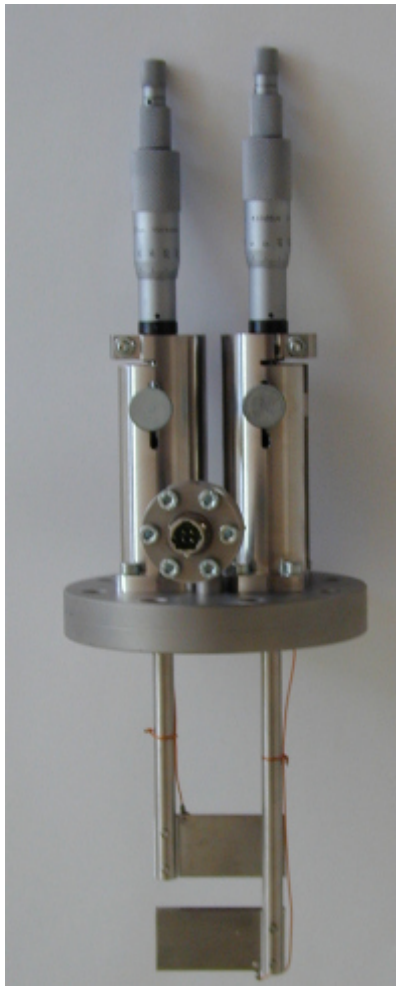
NTG Neue Technologien GmbH is a worldwide operating mechanical engineering company located in the heart of the European Union.

From January first 2011 NTG has taken over well known company PET-Darmstadt owned by Dr. P. Strehl and H. Kraus.

The implementation of PET's products and components into the NTG product range results in a considerable extension of the product range, especially in the field of accelerator physics and beam diagnostic.

This presentation gives an overview about NTG's competence and product range in this fields.

Manual Actuator, Twin Version



Mini-compressed Air Actuator



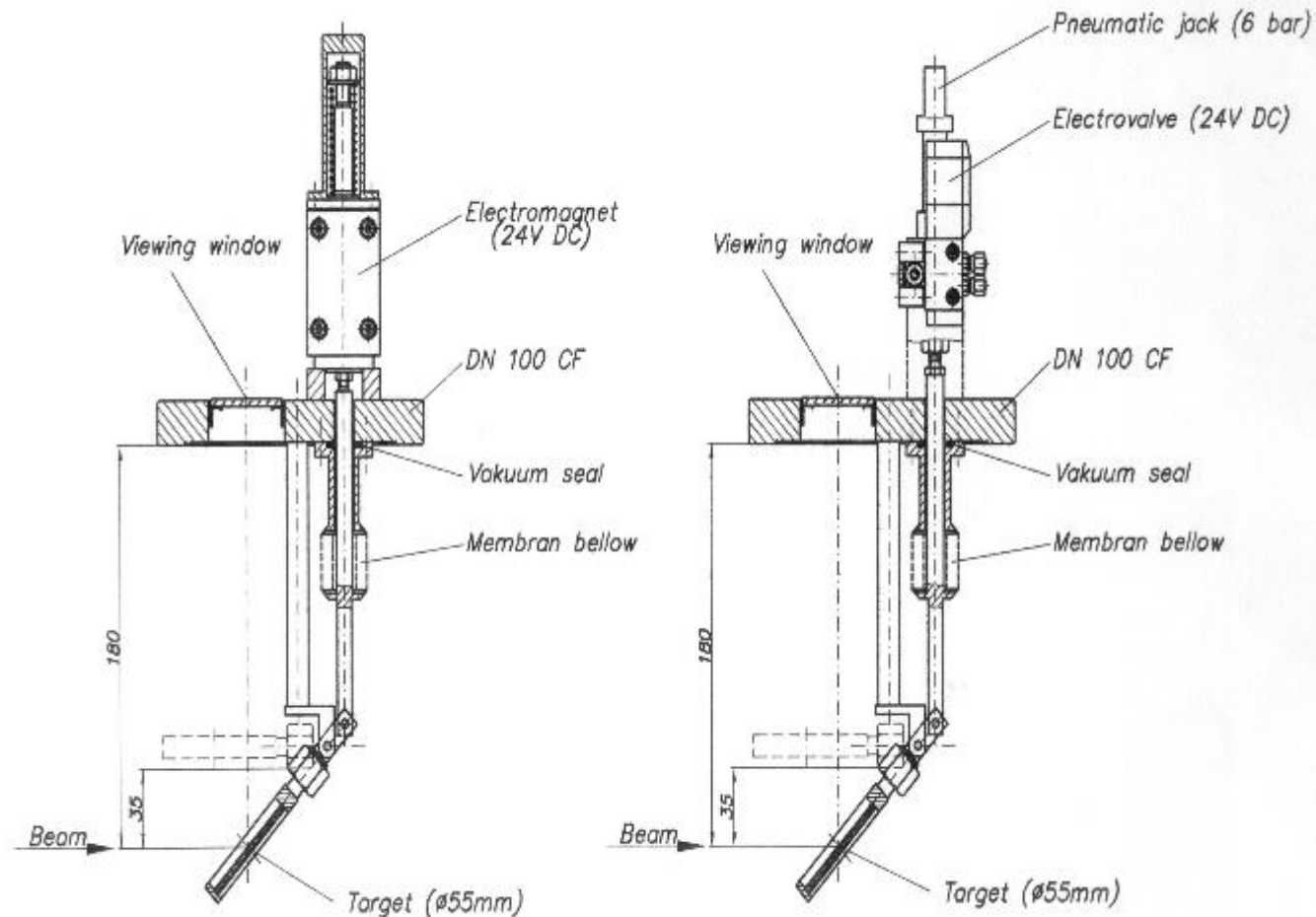
Stroke: 40 mm

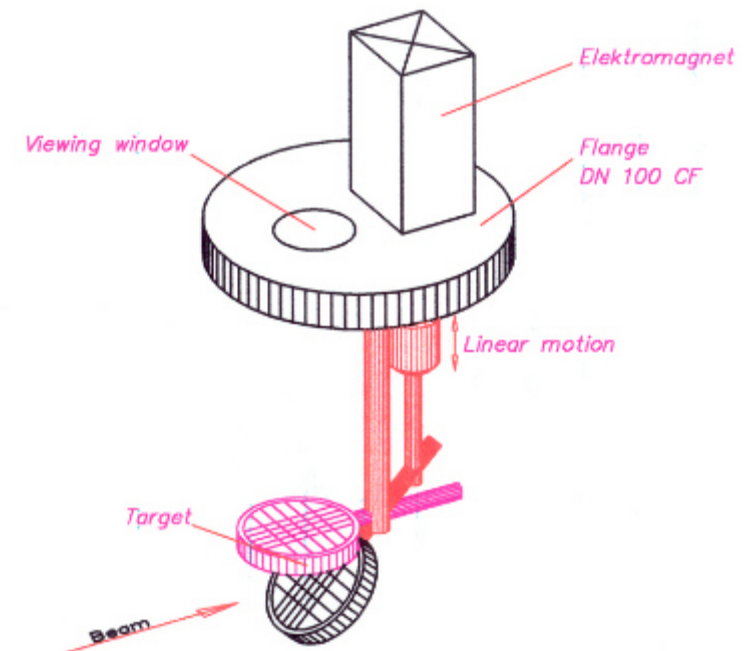
Membrane bellow Sealing,

CF – System,

Adjustable, ...

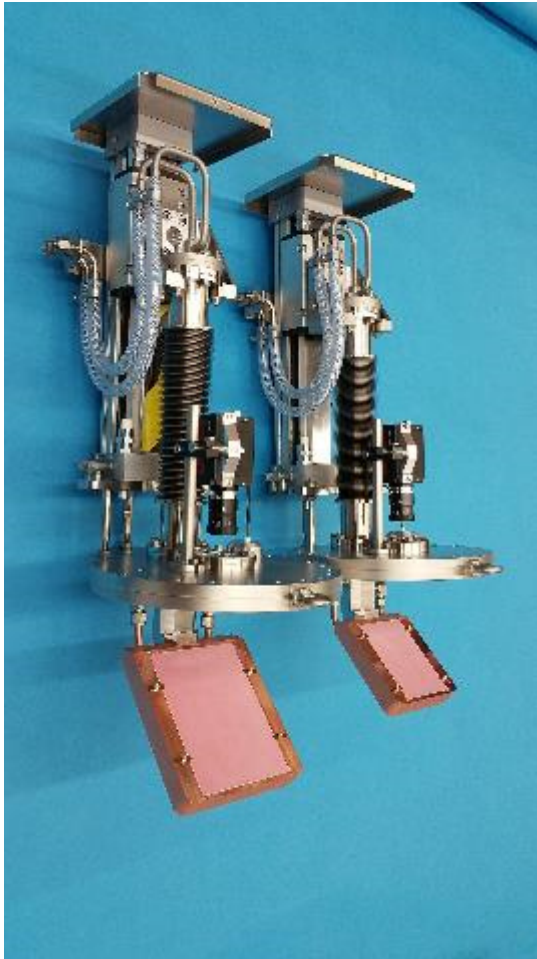
TWO VERSIONS OF FLIP MECHANISM ACTUATORS





Magnet driven version

Viewing Screen, attached to a compressed Air Actuator



Screen material:

Chomolux,

Sensitivity:

10E6 Protons/mm²/100ms

λ = 700 nm

Beam power: 2 kW

Compressed Air Actuator with cooled high Power Faraday Cup



Stroke: ~ 100 mm

Sealing: Membranbellow

Supporting flange: DN CF 100

Ball bearing spindle,

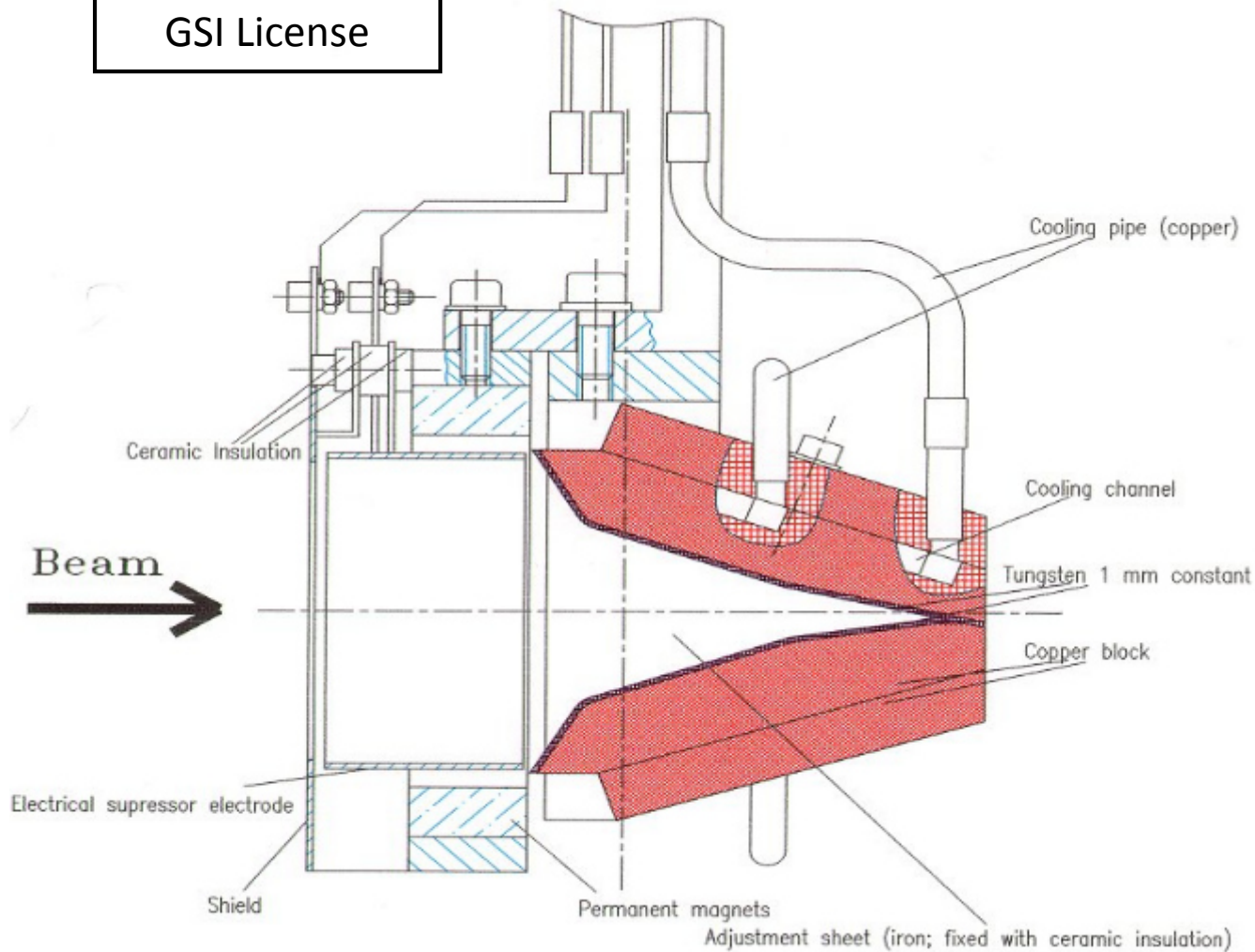
Limit switches

Adjustable

Different specifications available

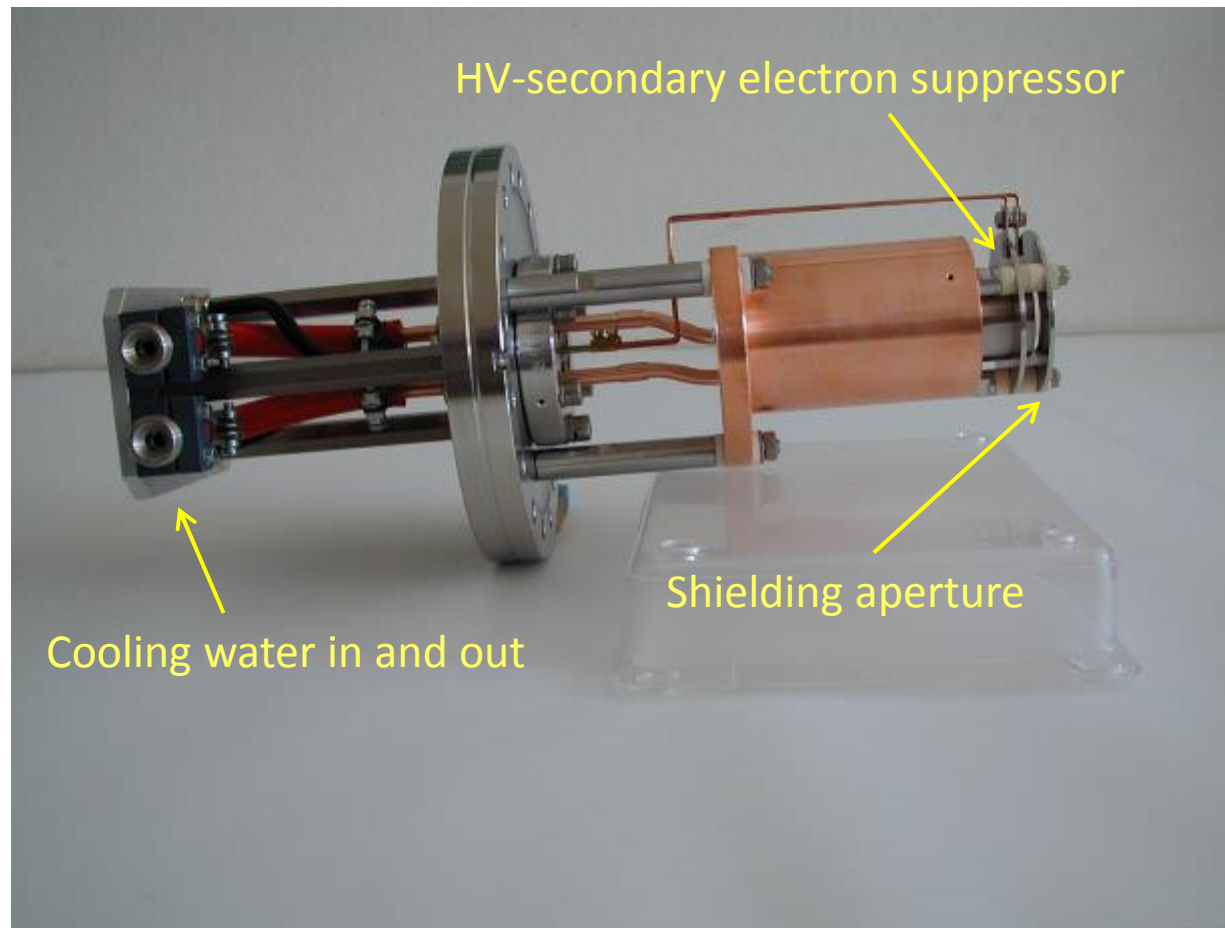
1.4 MW pulse, 200 μ s, 10 kW DC

GSI License

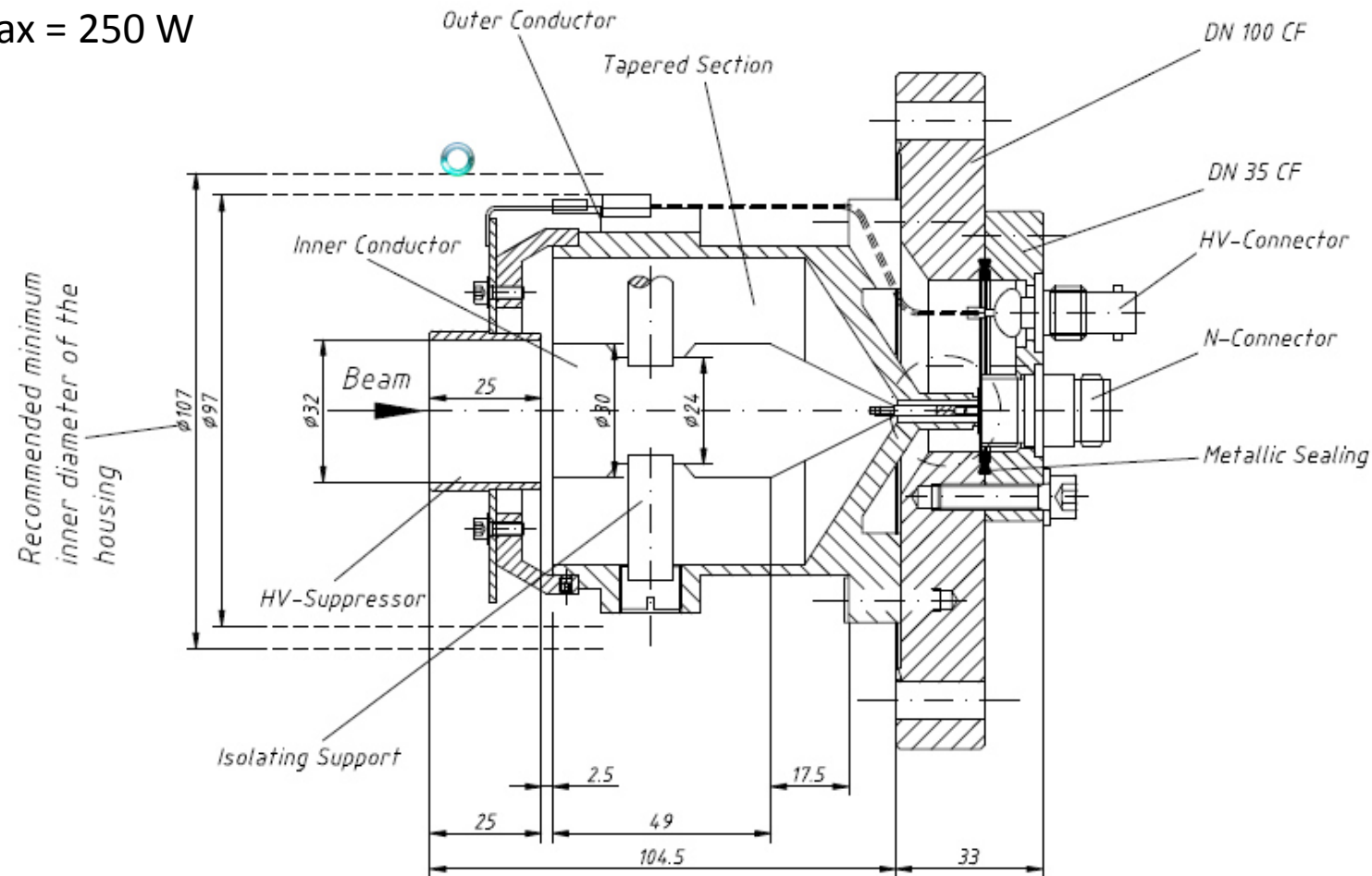


Cooled End Faraday Cup, no actuator , Stopper Material: Copper

Maximum Beam Power: 10 kW (DC)



$P_{\max} = 250 \text{ W}$



Coaxial Faraday Cup FC 62

Time Domain Reflectometer (TDR) – Impedance measurement
on the coaxial Faraday cup
with 25 ps pulse rise time. Corresponds to a bandwidth of 14 GHz

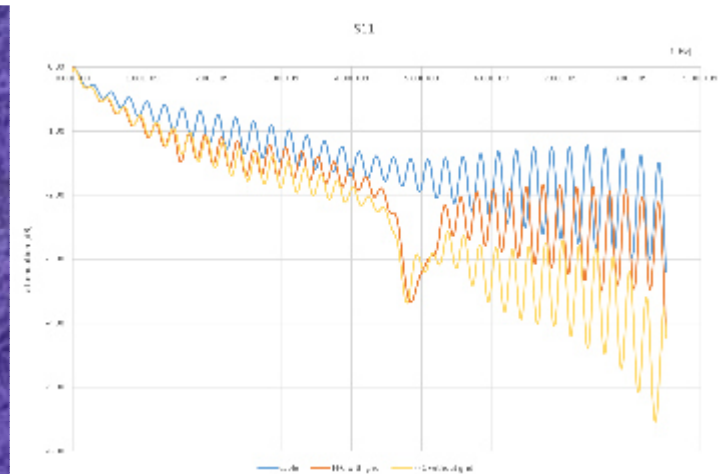
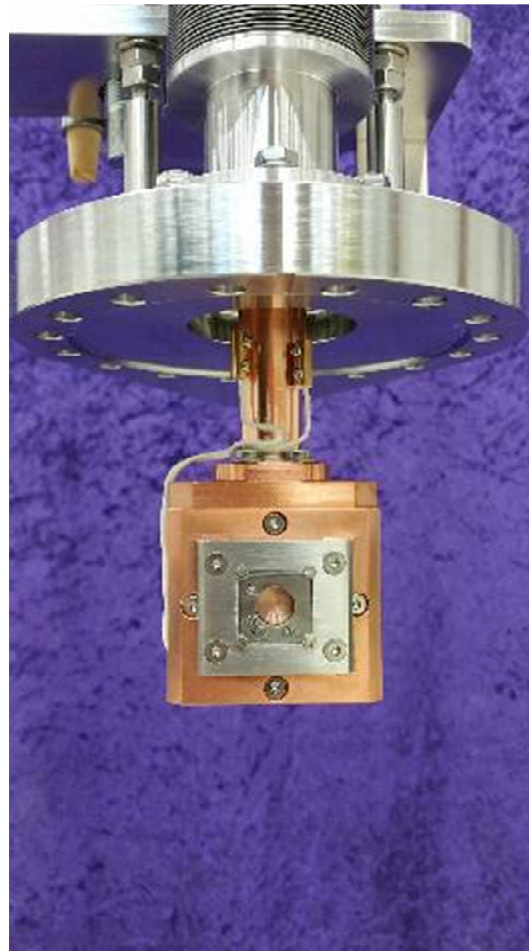


NTG Beam Diagnostics

Testing a large coaxial Faraday cup with a spectrum analyzer



Small Coaxial cup with advanced field suppression

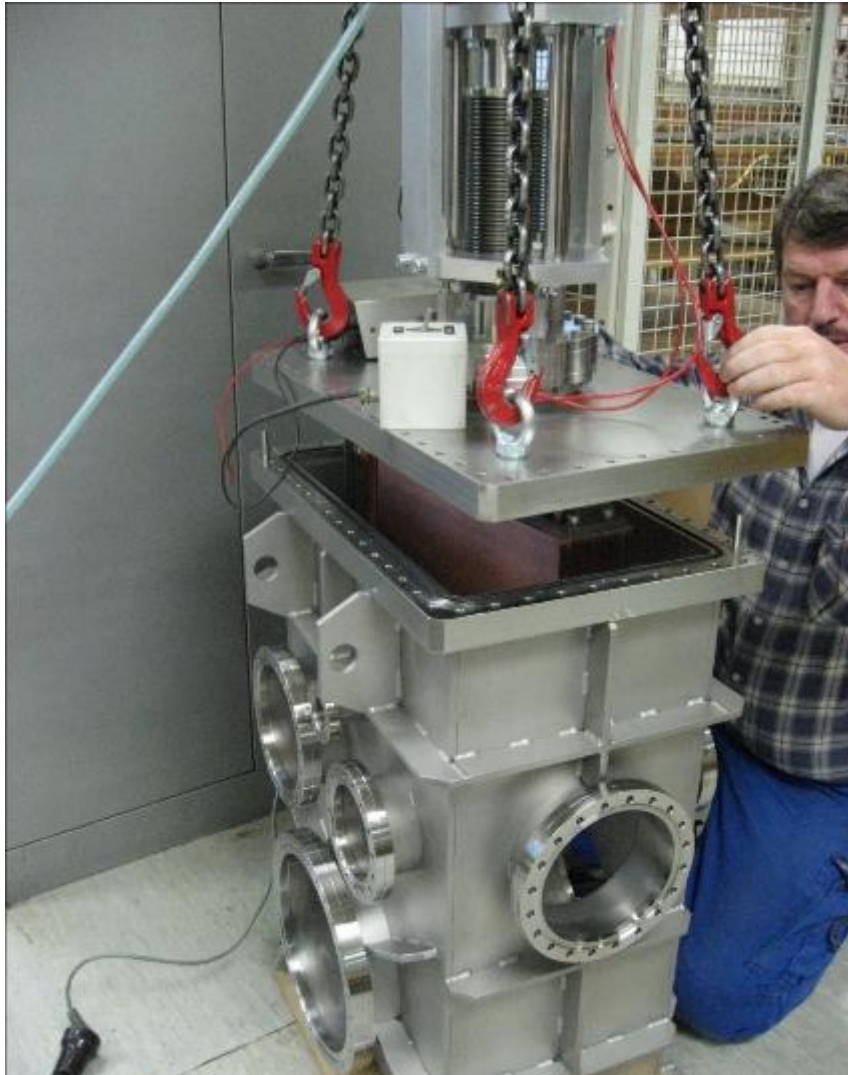


Stroke: ~ 100 mm
Sealing: Membranbellow
Supporting flange: DN CF 100
Ball bearing spindle,
Limit switches
Adjustable
Beam power: 100 W
Band Width: 4 GHz

2 kW High Power Coaxial cup



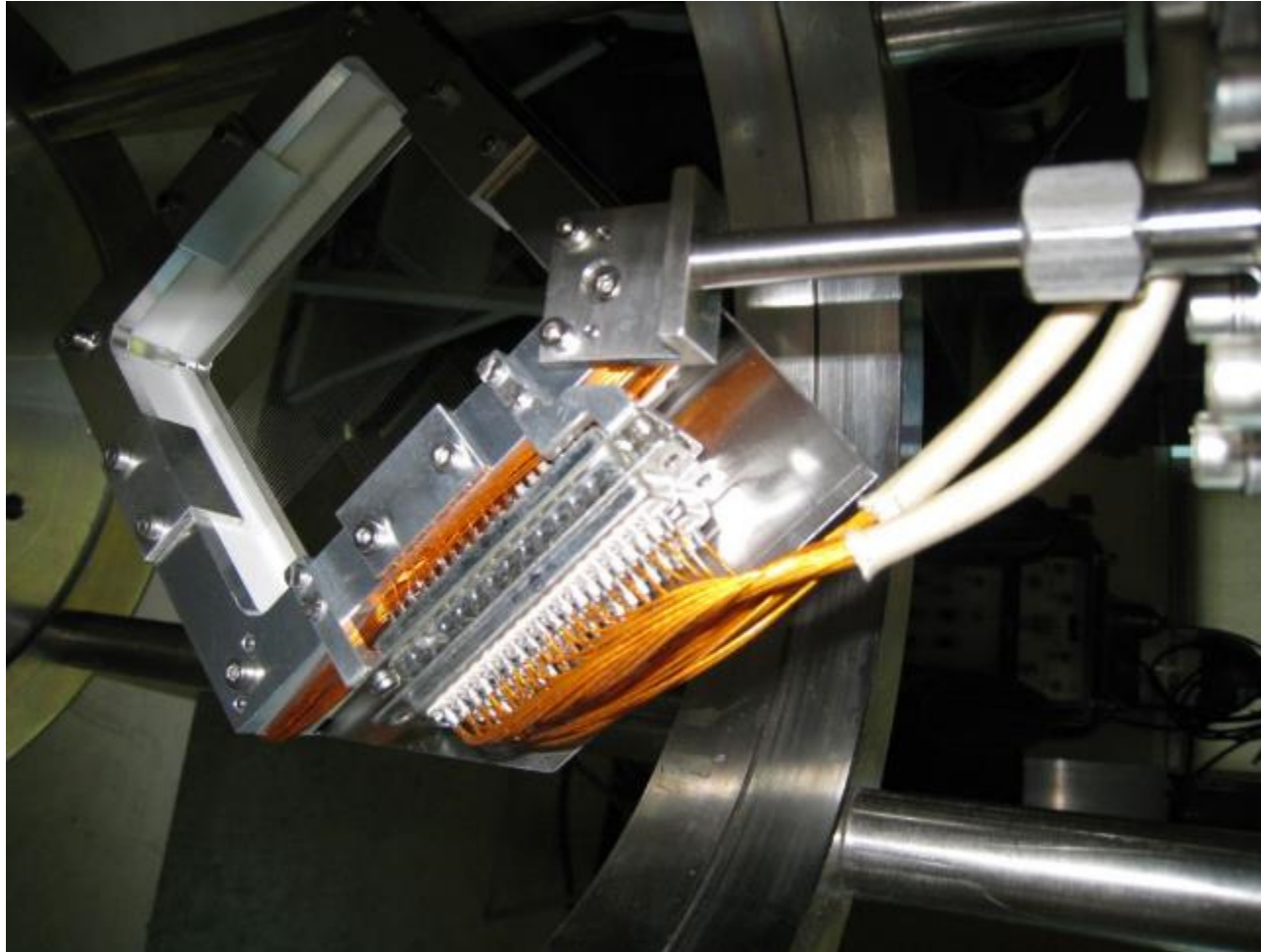
NTG *Beam Diagnostics*



FC for high intense beams: 120 keV Protons, 25 kW DC, available with CARBON stopper



Emittance measuring system based on a stepping motor driven crossed slit and a profile grid (see next foil). Both units mounted onto a 45 degree Port.

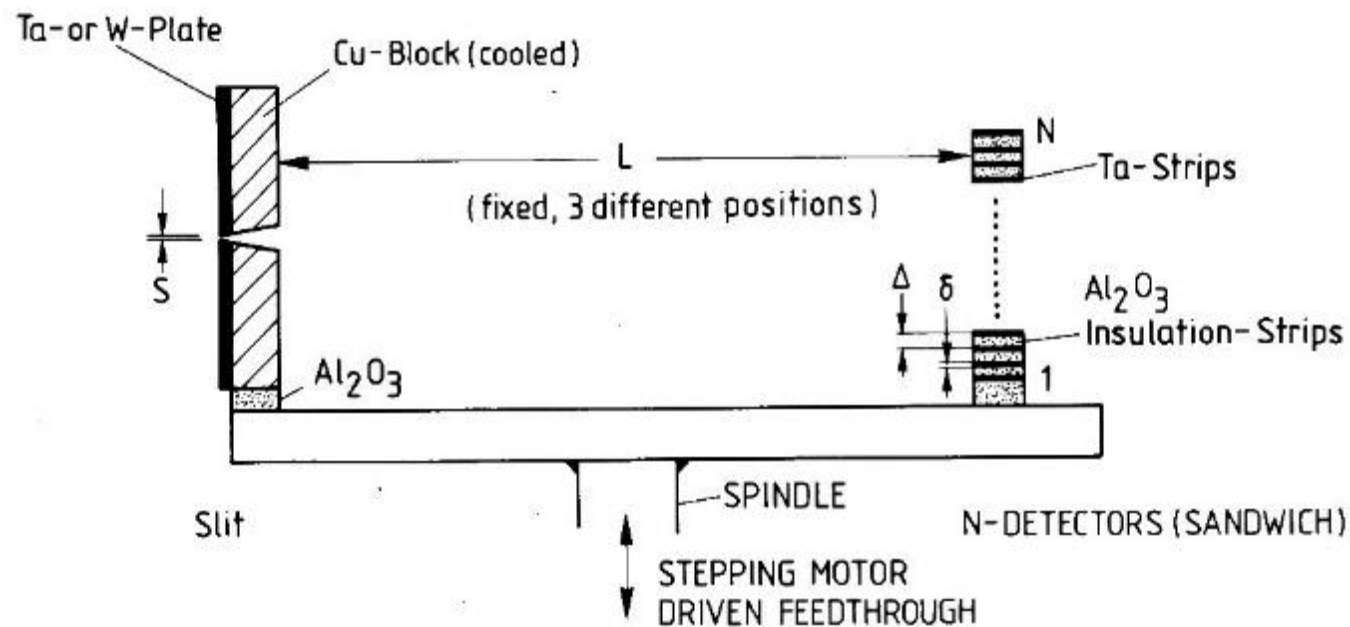


Profile grid mounted onto a 45 degree port, provided for emittance Measuring. The grid is driven through the beam by a stepping motor



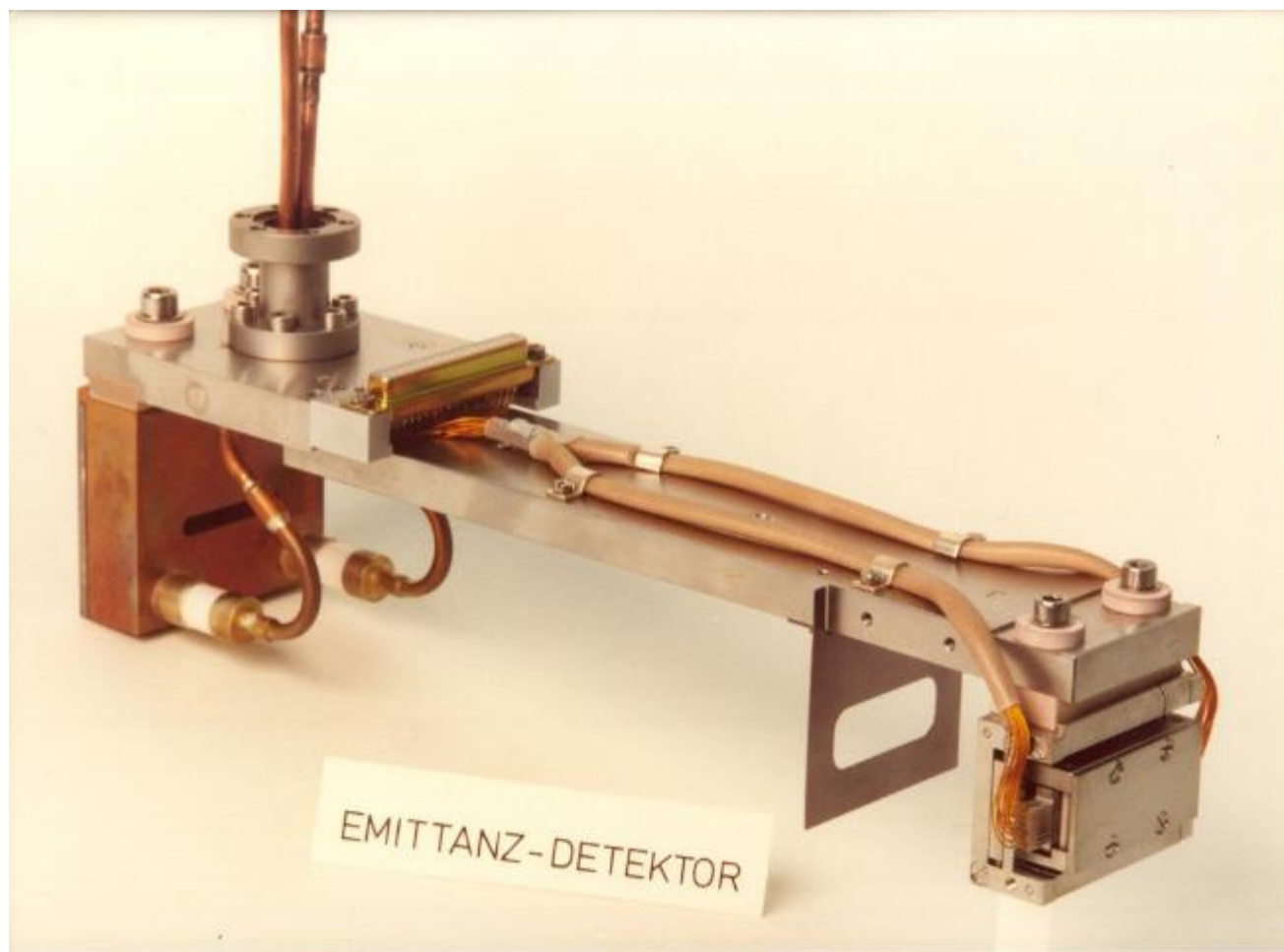
Another Scheme of an Emittance Measuring Device

Slit with detector sandwich mounted on one stepping motor driven bar

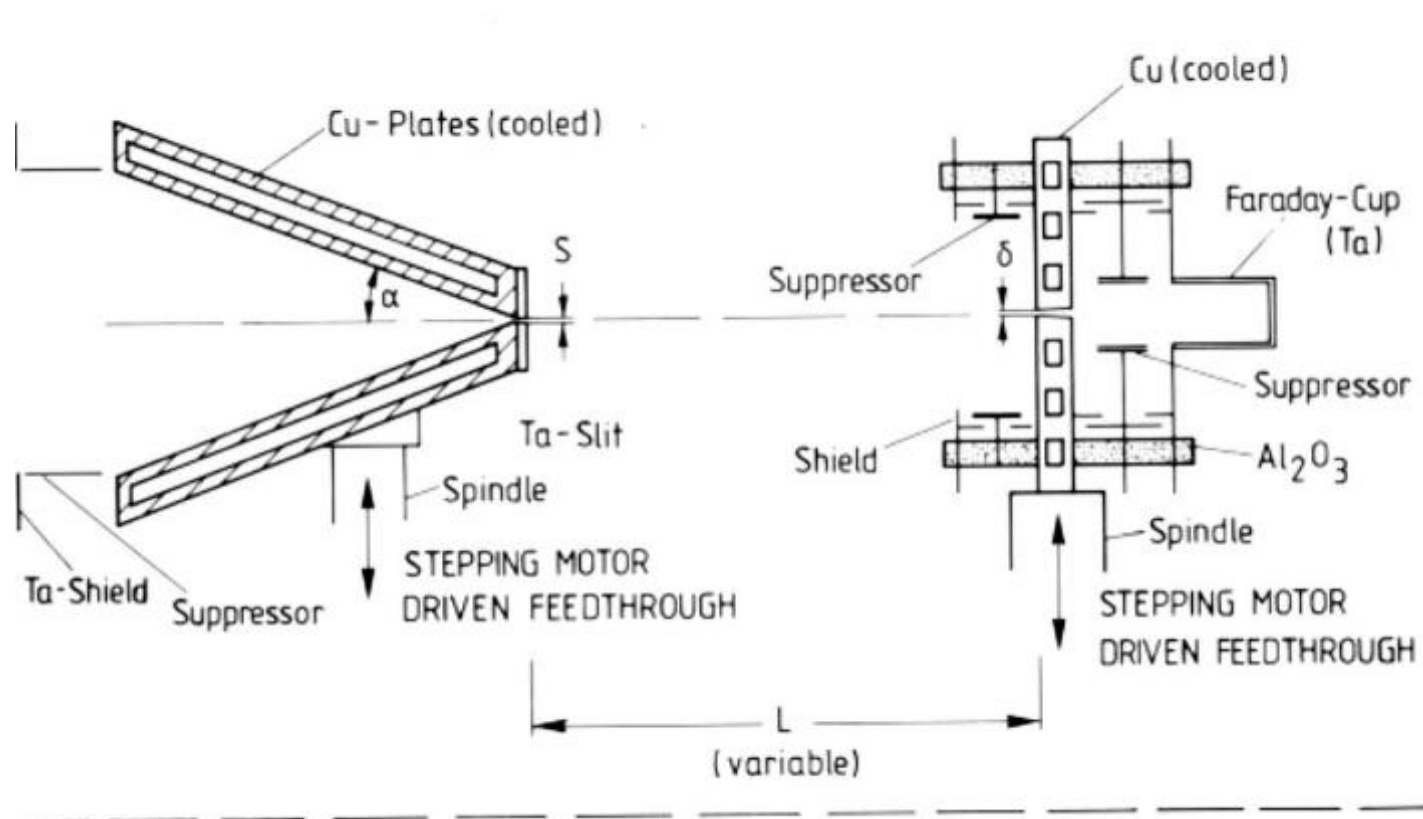




Slit-Sandwich Detector



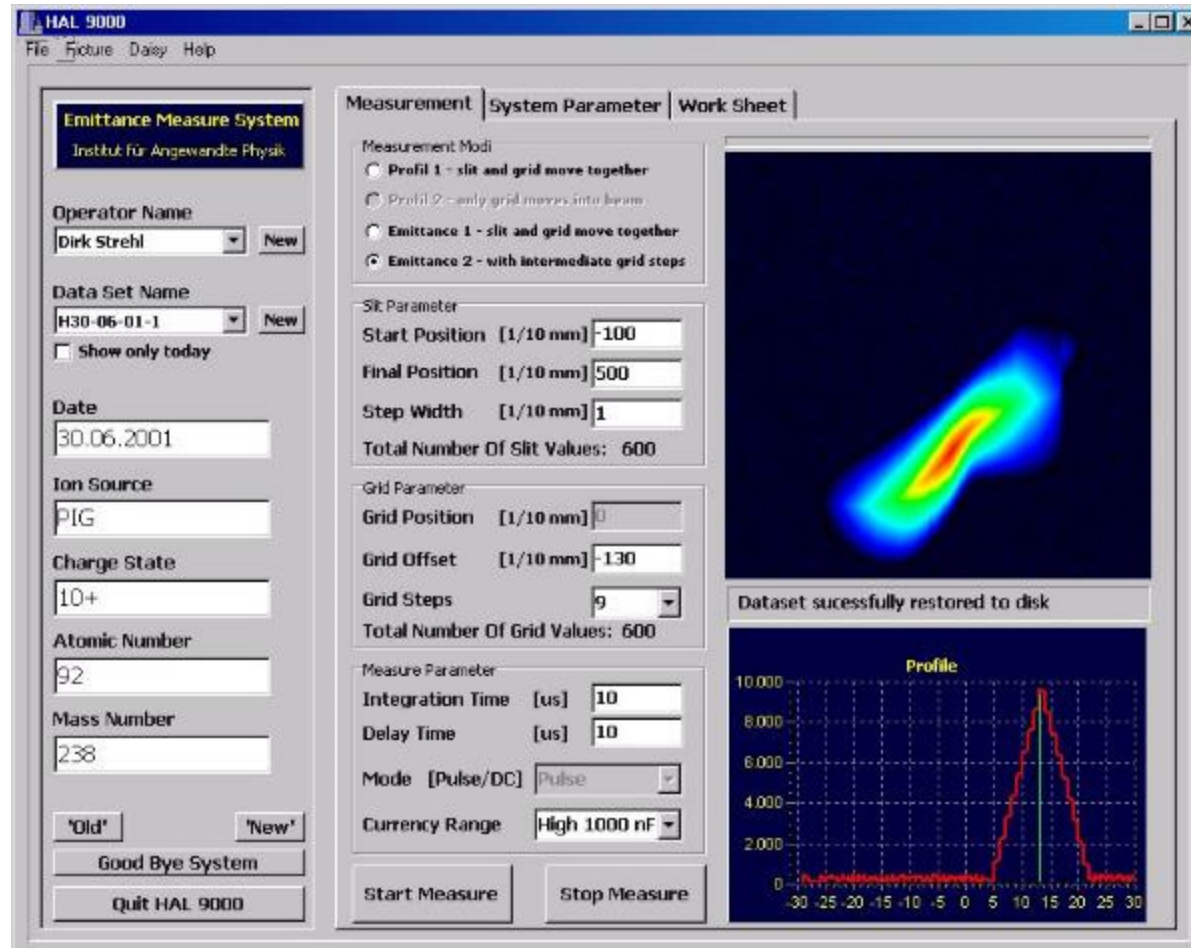
Scheme of Emittance measuring system, provided for intense beams



Allison Scanner



PC-Menu for Setup of an Emittance measuring System



HAL 9000
File Picture Daisy Help

Emittance Measure System
Institut für Angewandte Physik

Operator Name: Dirk Strehl [New]

Data Set Name: H30-06-01-1 [New]

☐ Show only today

Date: 30.06.2001

Ion Source: PIG

Charge State: 10+

Atomic Number: 92

Mass Number: 238

[Old] [New]

[Good Bye System] [Quit HAL 9000]

Measurement | System Parameter | Work Sheet

Measurement Modi:

- ☐ Profil 1 - slit and grid move together
- ☐ Profil 2 - only grid moves into beam
- ☐ Emittance 1 - slit and grid move together
- ☒ Emittance 2 - with intermediate grid steps

Slit Parameter:

Start Position [1/10 mm]: 100

Final Position [1/10 mm]: 500

Step Width [1/10 mm]: 1

Total Number Of Slit Values: 600

Grid Parameter:

Grid Position [1/10 mm]: 0

Grid Offset [1/10 mm]: 130

Grid Steps: 9

Total Number Of Grid Values: 600

Measure Parameter:

Integration Time [us]: 10

Delay Time [us]: 10

Mode [Pulse/DC]: Pulse

Currency Range: High 1000 nF

[Start Measure] [Stop Measure]

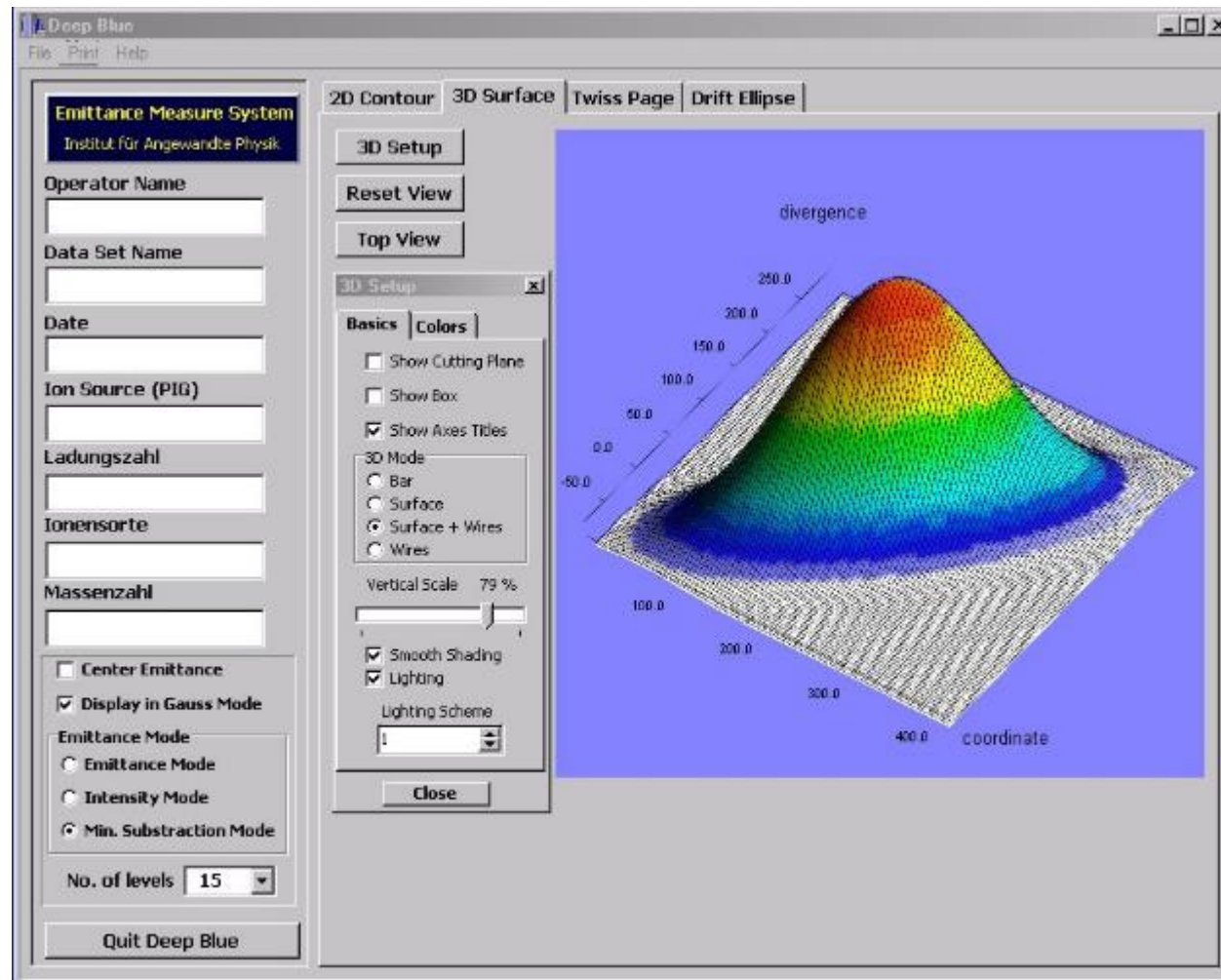
Dataset sucessfully restored to disk

Profile

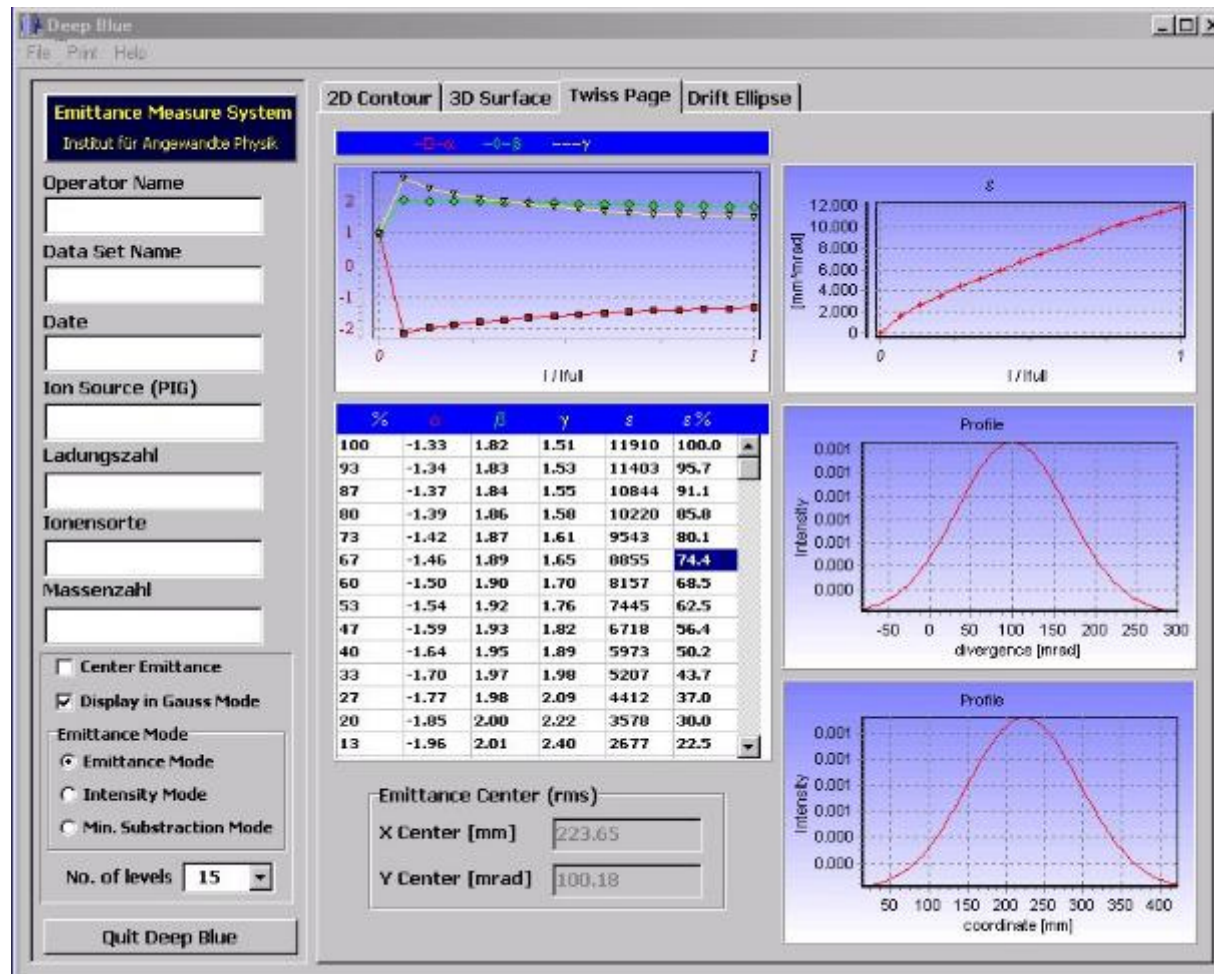
10.000
8.000
6.000
4.000
2.000
0

-30 -25 -20 -15 -10 -5 0 5 10 15 20 25 30

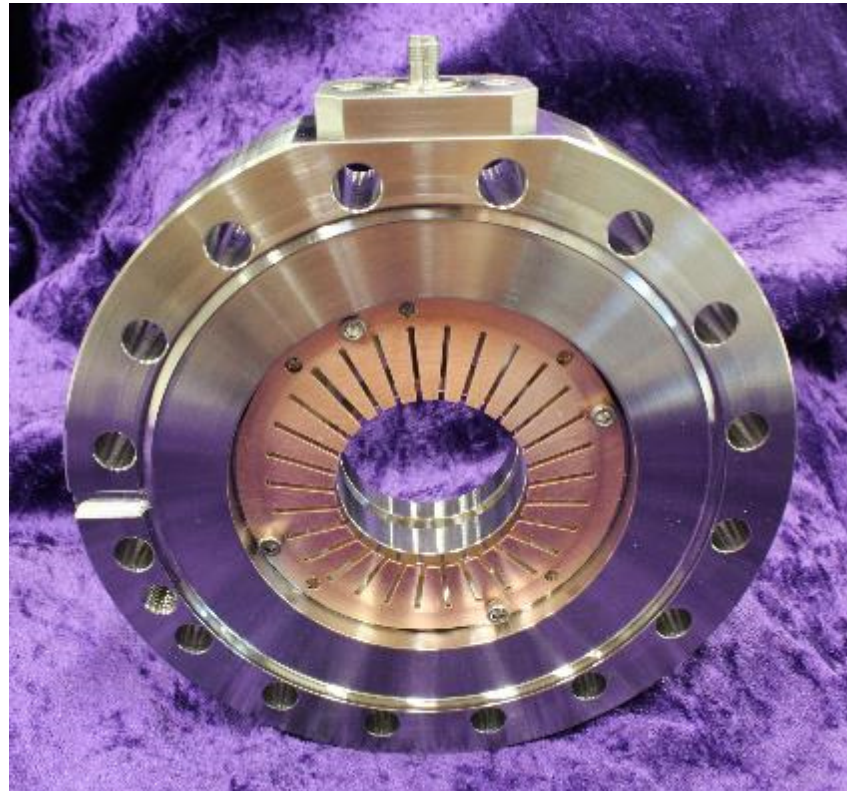
3D Presentation of Emittance Data



Evaluation of Twiss Parameters

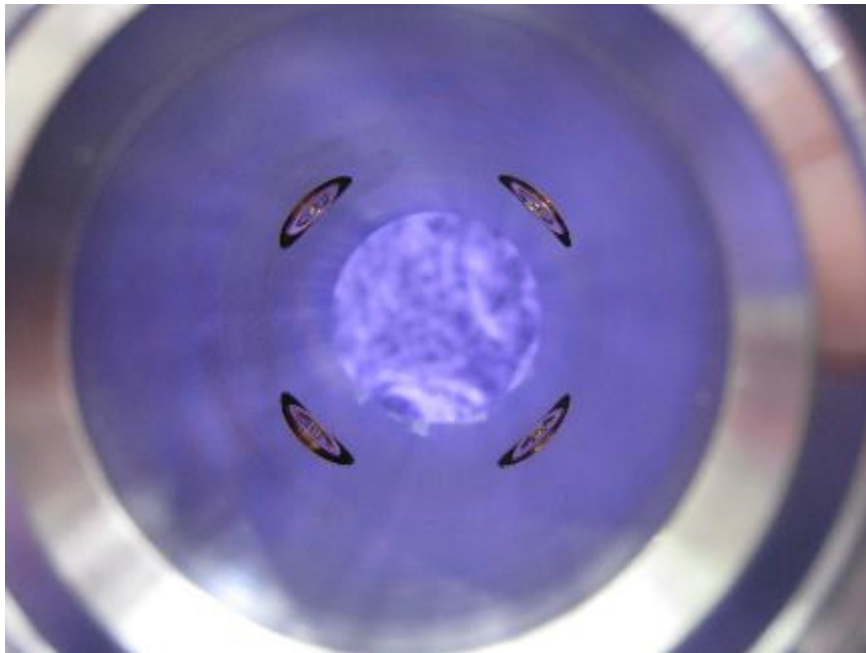


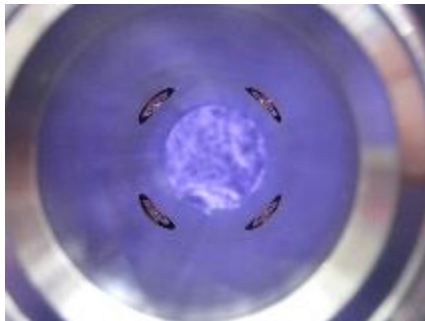
Capacitive Pick-up Provided for Measurements in the Longitudinal Phase Space and TOF



Impedance \rightarrow 50 Ohms, Bandwidth \rightarrow 2 GHz Aperture 35 mm (Standard, other possible)

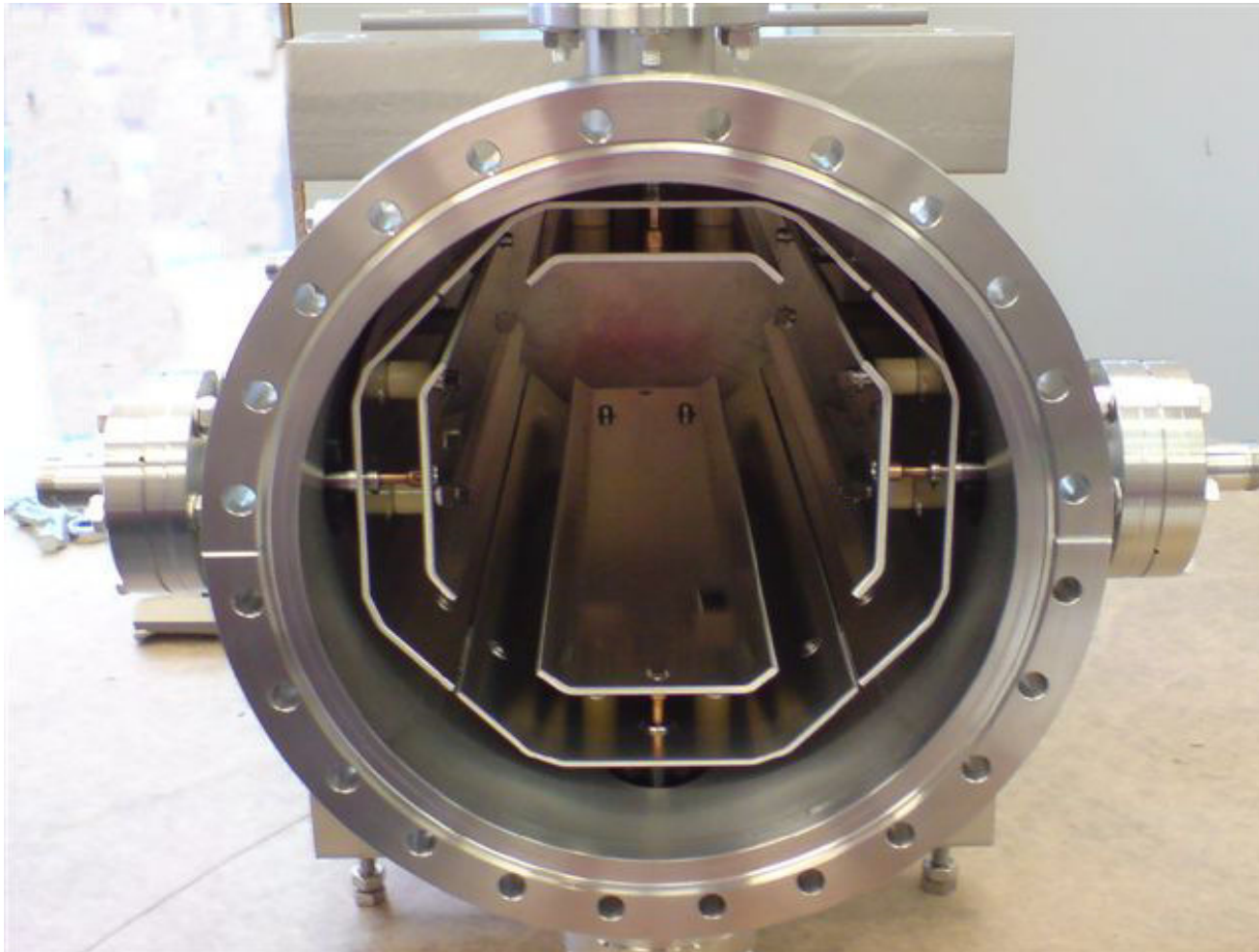
Beam Position Monitor BPM



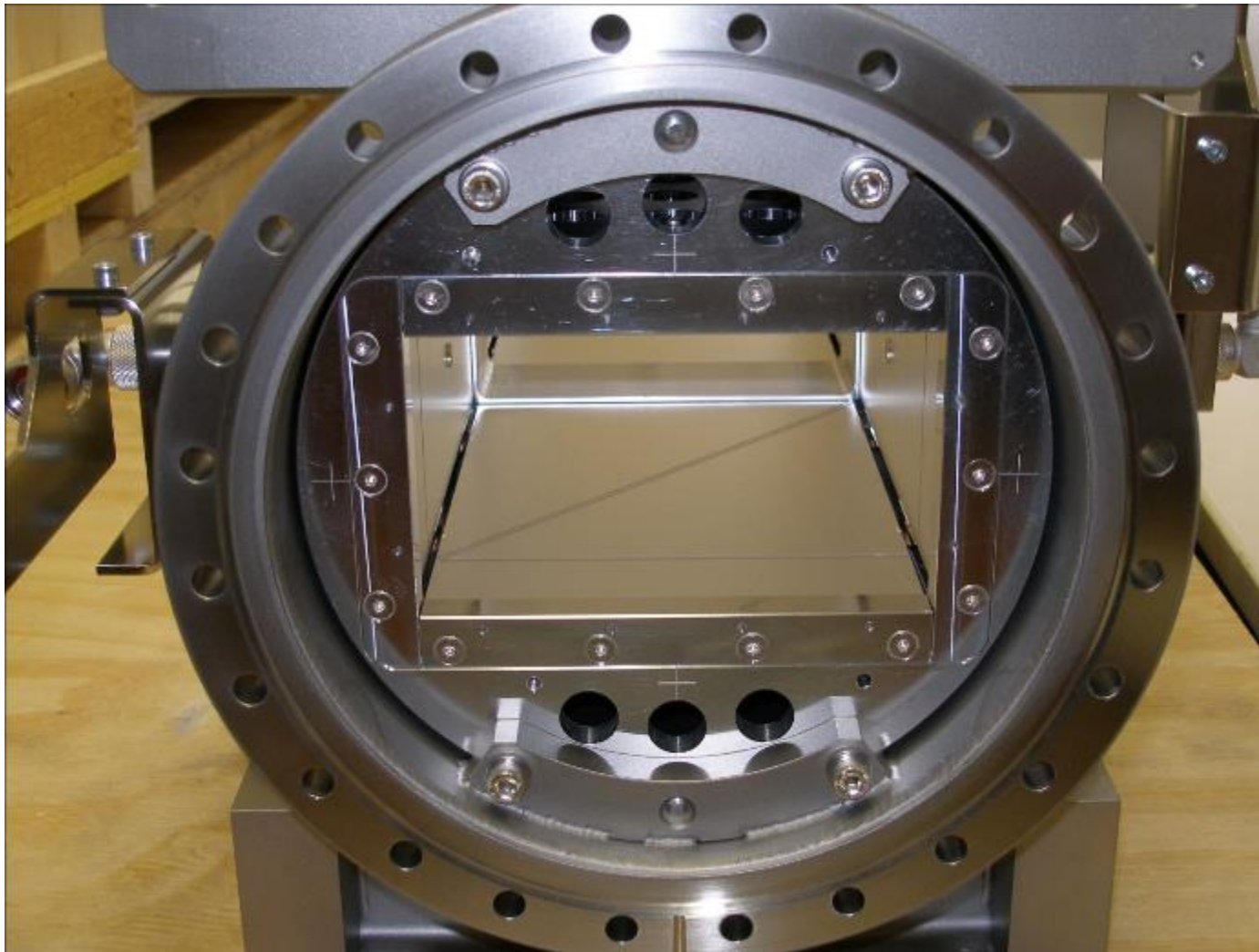


| | |
|----------------------|-----------------|
| - Principle: | capacitive |
| - Impedance: | 50 Ohms |
| - Bandwidth: | ca. 2 GHz |
| - Electrodes: | 4 (disk-shape) |
| - Diameter: | 7 mm |
| - Aperture: | 30 mm |
| - Sum signal: | ca. 20-40 pA/e |
| - Difference signal: | ca. 3-5 pA/e |
| - Connector: | SMA-coax |
| - Material (housing) | stainless steel |
| - Insulation: | PEEK |

50 Ohms Pick up System Provided for Schottky, BTF and K-Modulation in Synchrotrons



Beam Positions Monitor (BPM) for Synchrotrons





Set of Beam Positions Monitors (BPM) for Synchrotrons





Large Profile Grid with compressed Air Actuator



Actuator:

Stroke: 200 mm

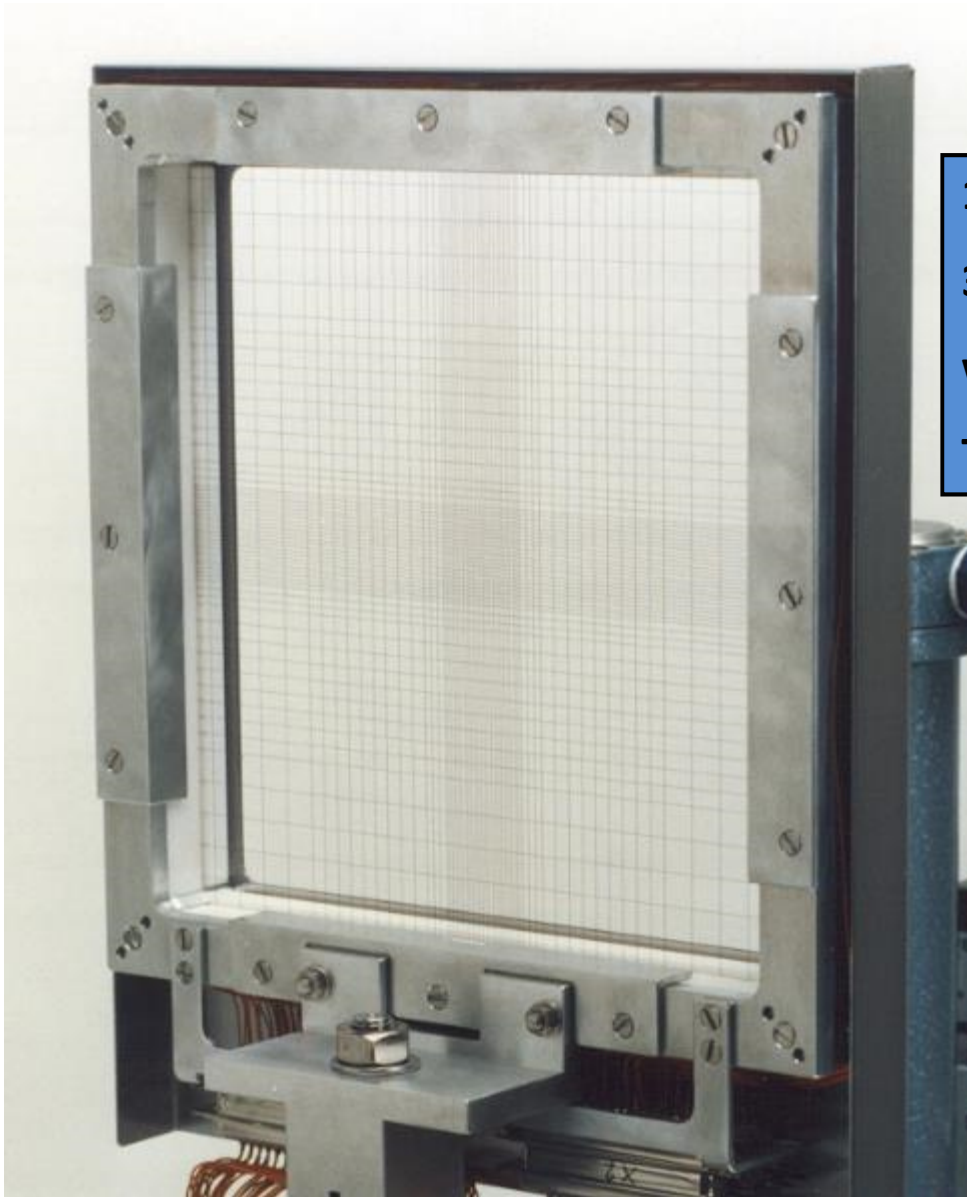
Membrane bellow

DN CF 250

**Three slide bars,
sliding bearing,**

Limit switches

Adjustable, ...

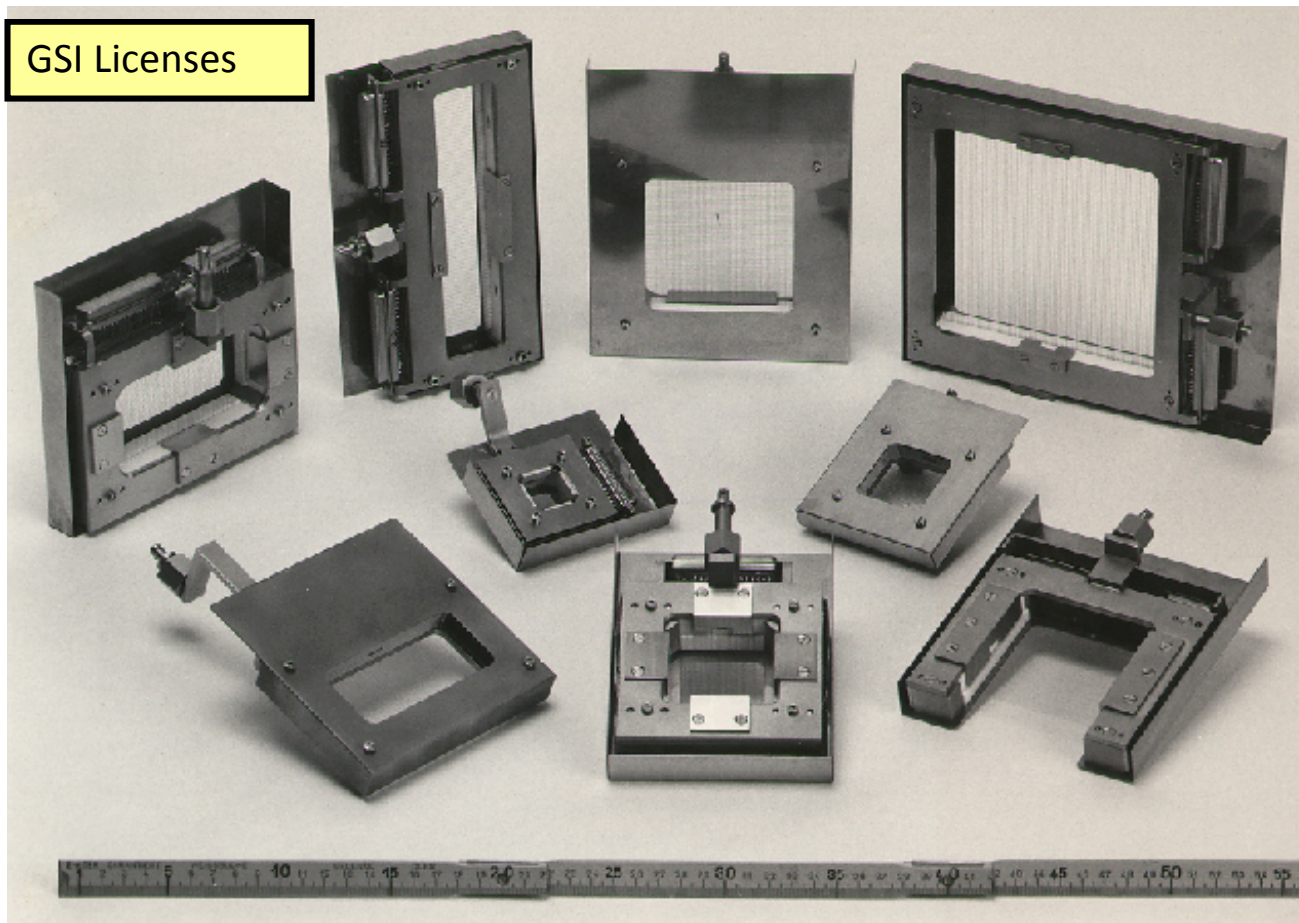


**170 x 170 mm, spacing: 1.5 mm (center),
3 mm, 4.5 mm (most outside),
wire diameter 0.1 mm,
Tungsten-Rhenium wires**



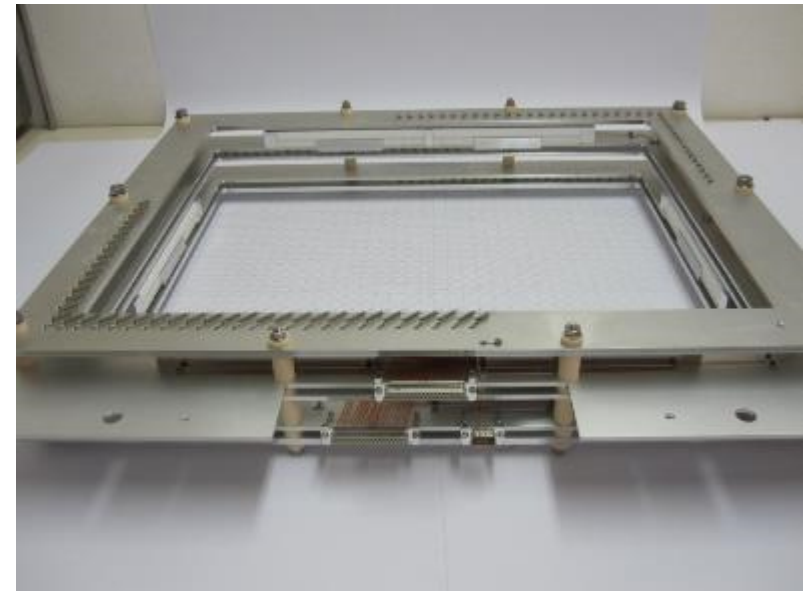
**Harp provided for Emittance Measurements.
The Harp measures the Beam Profile
behind a Slit moved through the Beam**

Collection of Profile Grids



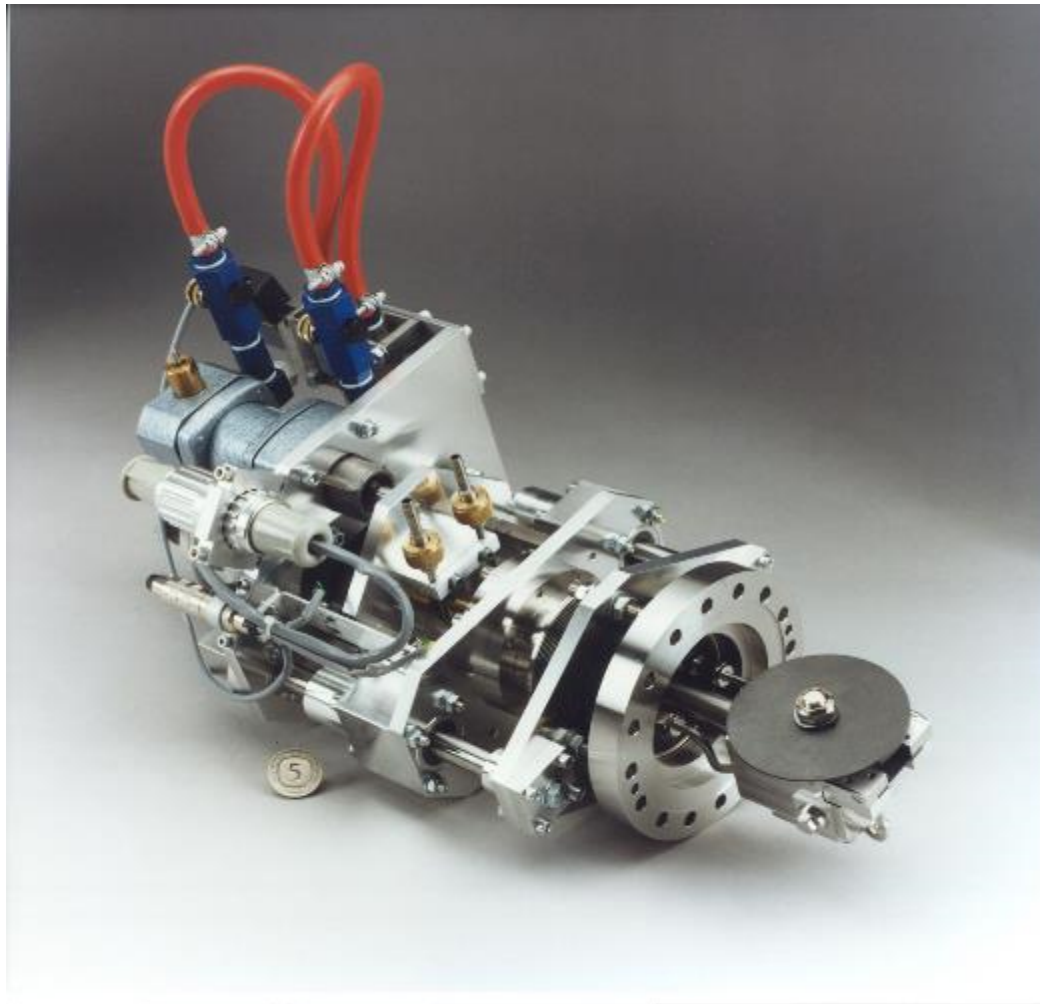


Frames of a 5 Plane Large Profil Grid. Dimension about 480 x 640 mm

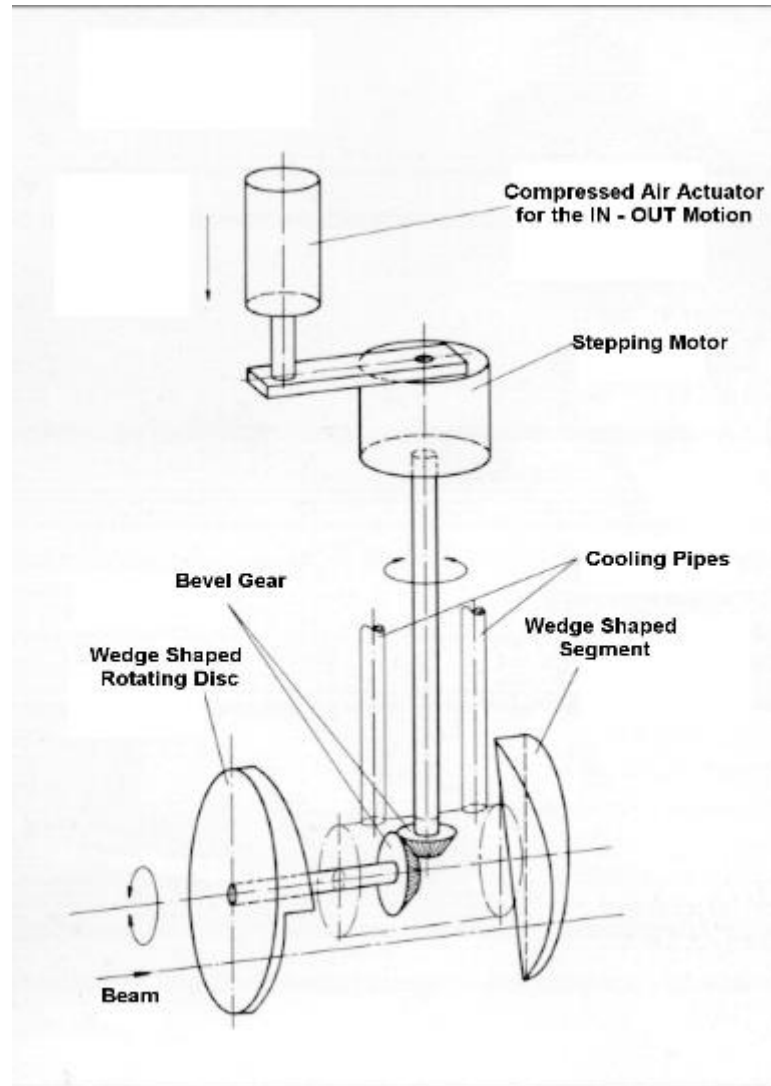




NTG – Energy Moderator MD 05



Working principle see
next foil



Diameter of the discs: 86 mm

Thickness variation : .24 mm 3.94mm

Material: Graphite

Stroke of the actuator: 50 mm

Minimum step width: 0.72 degrees

Maximum frequency: ca. 5 Hz, wobble mode

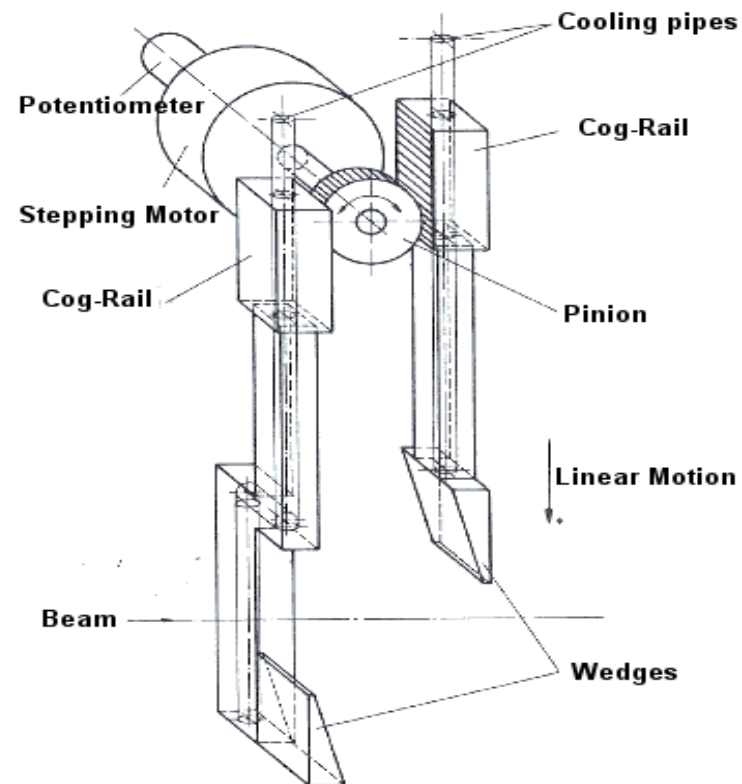
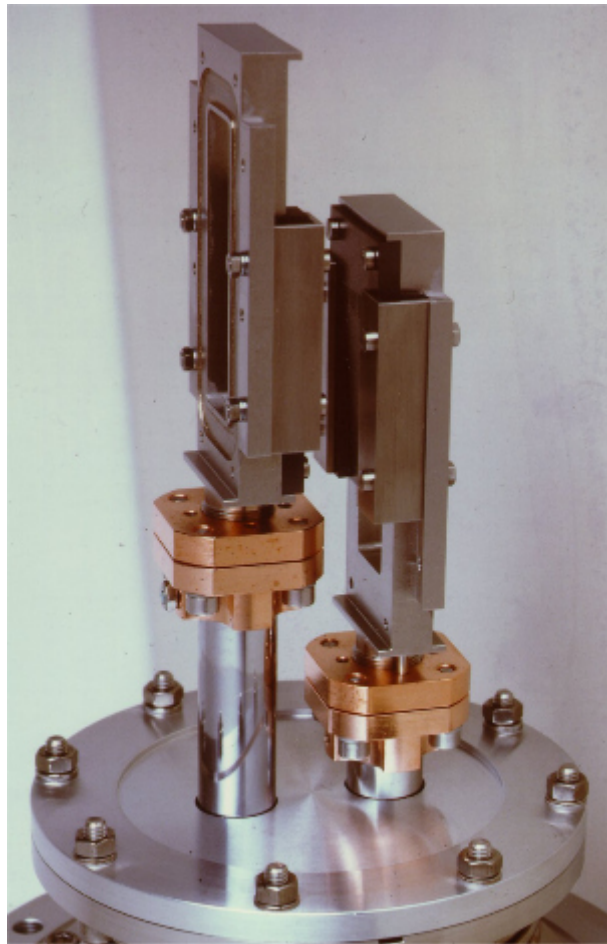
Max. beam power loss: 500 Watts/wedge

Max. energy range: 39-45 MeV protons

Control PC or microprocessor

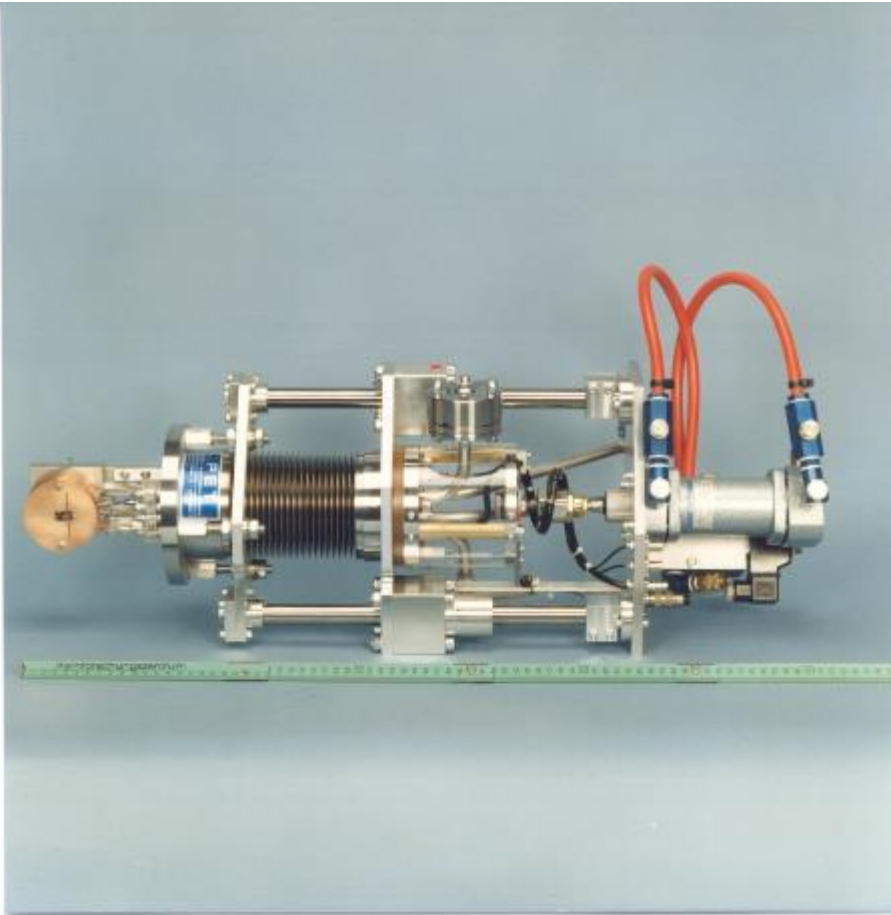
Applications → in Material Research

NTG-Energy Moderator MD04



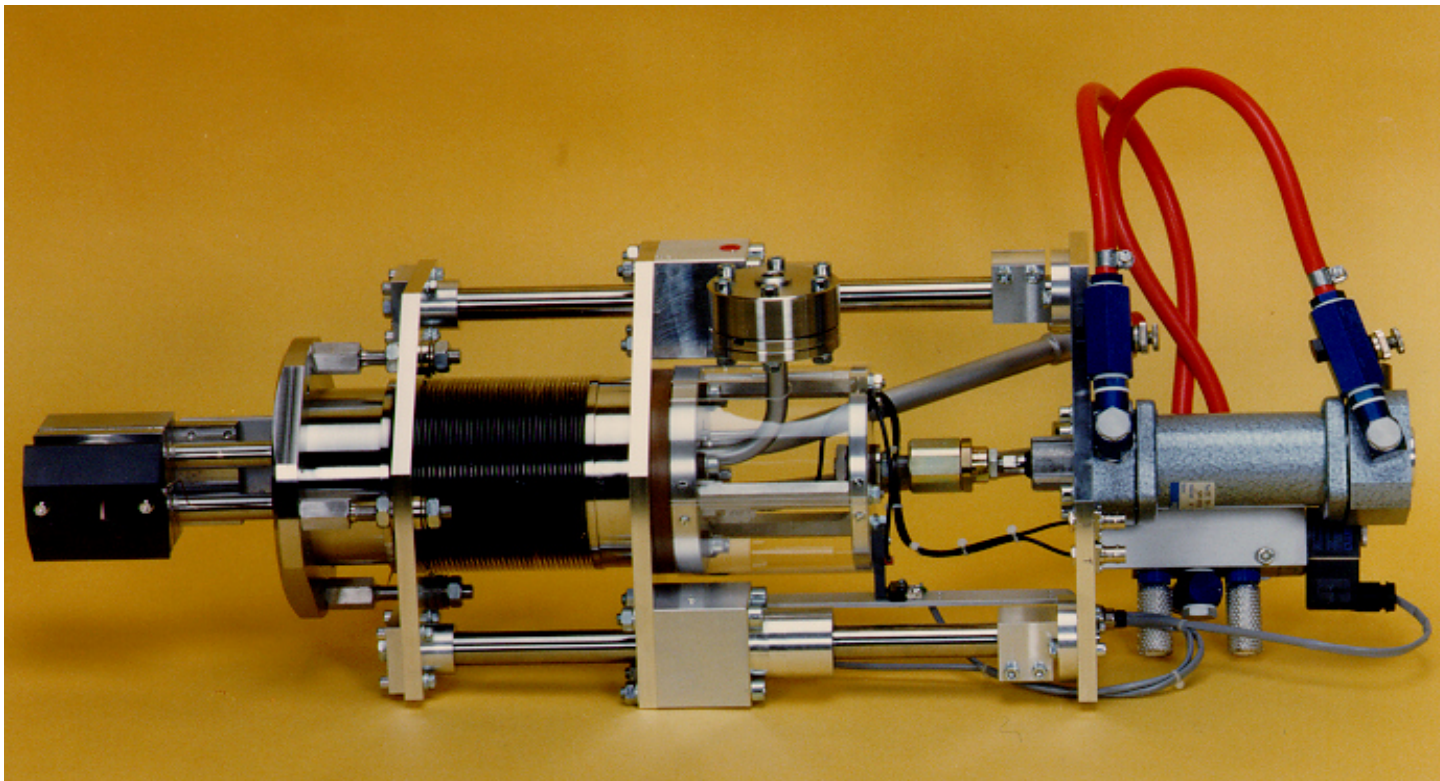
Applications → in Material Research

Irradiation Probe BE 01 with compressed Air Actuator and Probe Heating



Applications → in Material Research

High Power Aperture (Graphite), mounted onto a compressed Air Actuator



Two Beam Experimental Setup Equipped with Diverse Diagnostic Elements

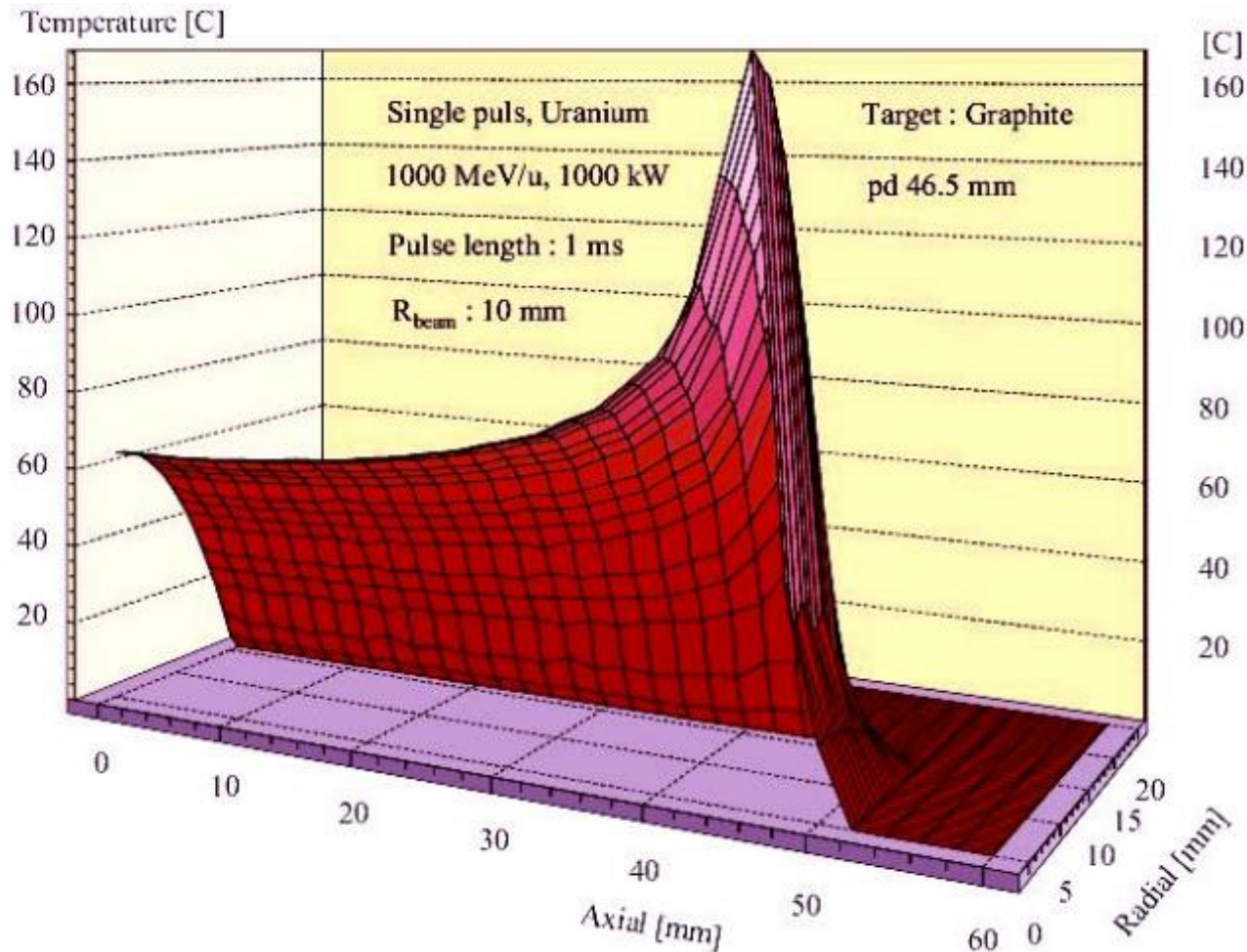


Physics

- **Design of beam diagnostic systems**
- **System analysis**
- **Signal calculation for all kinds of monitors**
- **Thermal calculations**
- **High intensity beam diagnostics**
- **Emittance measuring systems**
- **Development of application software**
- **Particle dynamics**
- **Estimation of space charge effects**

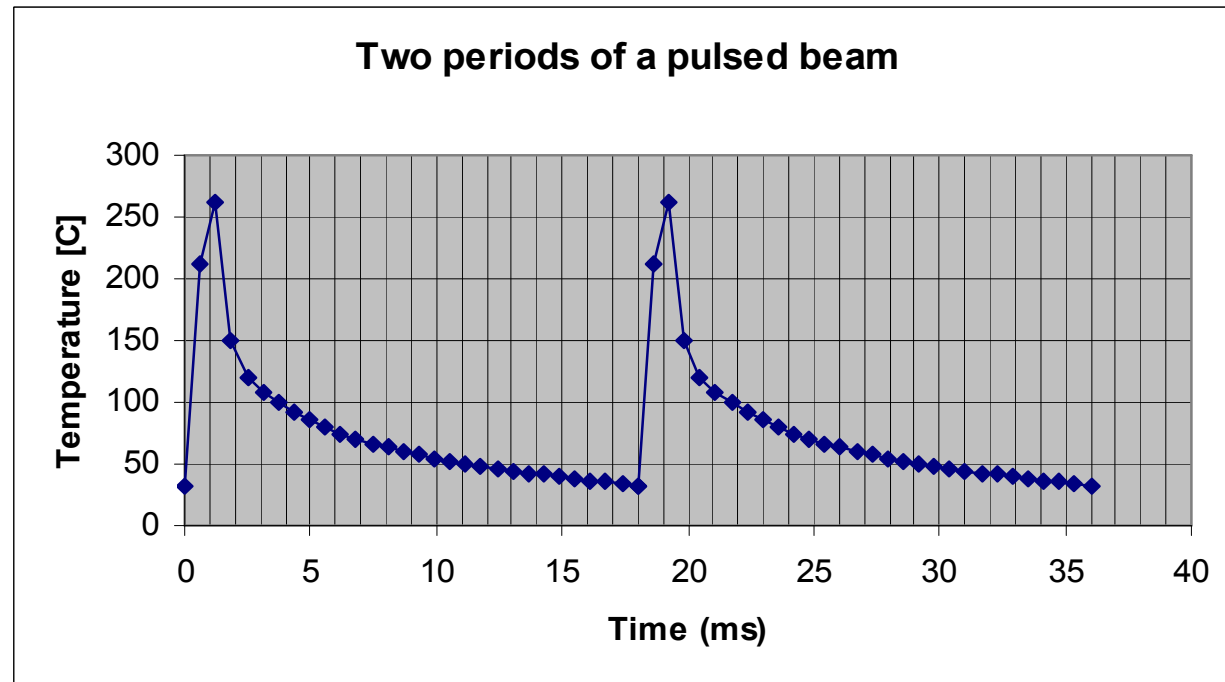
Consulting

Calculations, some Examples

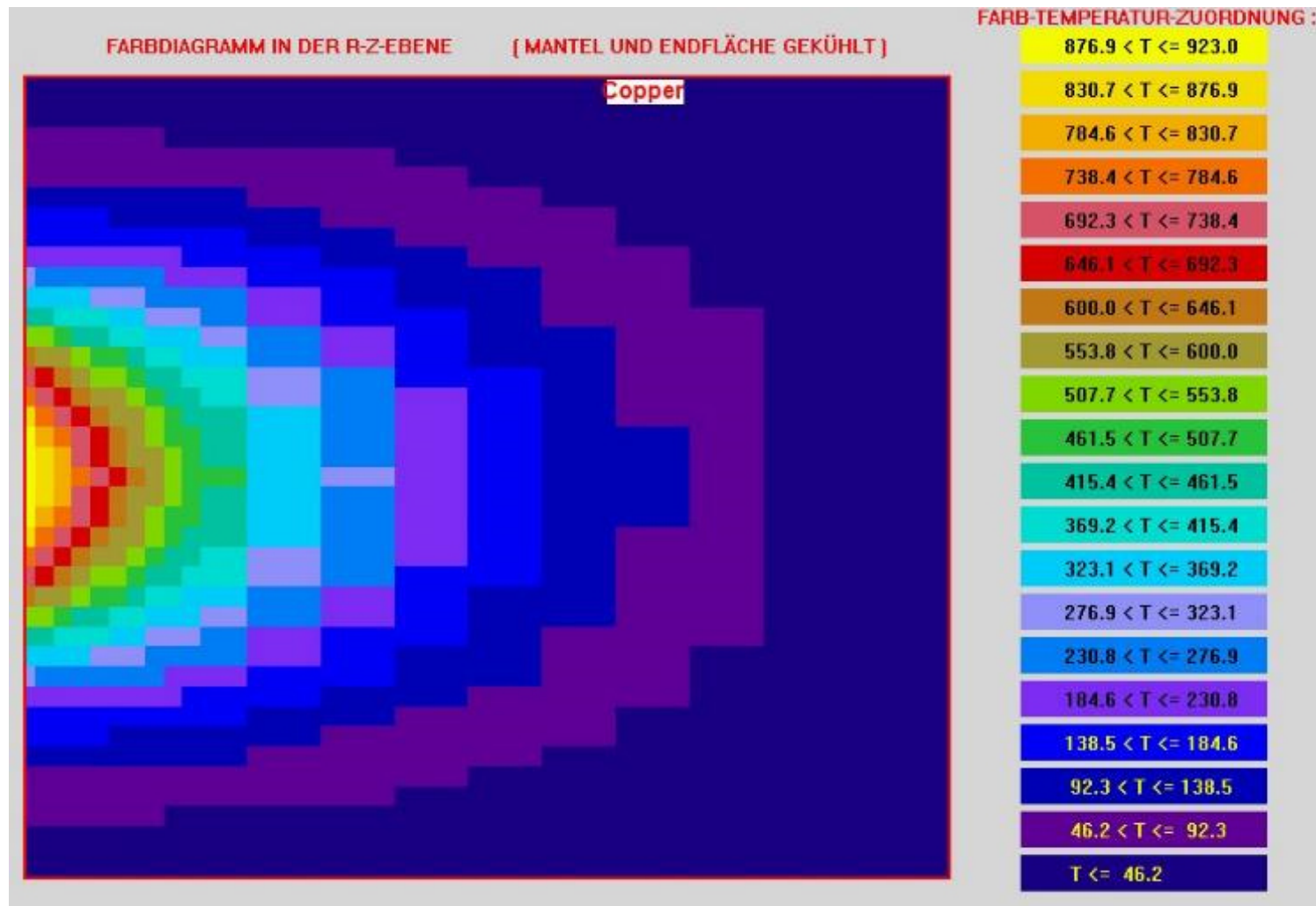


Solution of the Partial Differential Equation of Heat Transfer

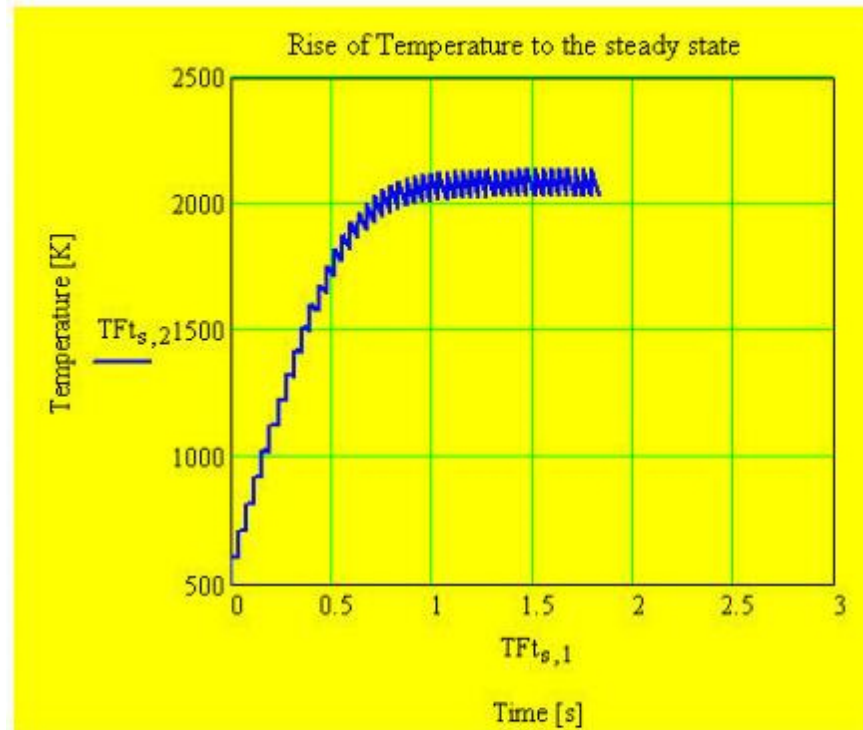
$$\frac{\partial T}{\partial t} = a^2 \cdot \Delta T + \frac{\dot{Q}(x, y, z)}{V}$$



The example shows the heating of a target by a pulsed beam



The example shows the distribution of heat in a circular beam stopper hit by a DC beam



Calculation of the Maximum Thermal Load on a Profile Grid for a Pulsed Beam.
The Steady State is determined by Radiation according to the Stefan-Boltzman law.

$$\rho = 19.3$$

$$P_{\text{pmm}2} \cdot 100 = 1.2 \times 10^4$$

$$\Delta t = 2 \times 10^{-4}$$

$$f_r = 25$$

Tungsten/Re wires, [g/cm²]

[W/cm²]

pulse length, [s]

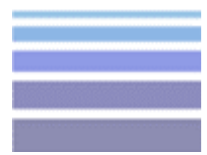
repetition frequency, [Hz]

Technics

Construction and manufacturing of:

- Beam diagnostic elements
- Experimental set-ups
- Moderators provided for energy degrading
- Elements for material research
- UHV-high temperature ovens
- Vacuum technics
- High precision mechanical devices

Project management



Technics

Construction and manufacturing of:

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Project management



Parameters Characterizing a Particle Beam

- Type of particle (may be: Electrons, Protons, Ions, Neutral Particles)
 - In case of ions mass number A , atomic number Z as well as the charge state of the ion is of interest
- Beam current:
 - DC (Remark: Also a DC beam may have a microstructure, respectively contain bunches)
 - Pulsed: One needs the pulse macrostructure as well as the microstructure (Bunch shape),
 - → FWHM, Repetition frequency

Continued → next Foil



- Beam energy:
 - In case of ions MeV/u is usual
- Beam spot size:
 - Diameter, if not a round beam it has to be specified.
 - Also the intensity distribution within the spot is of interest
- Beam emittance:
 - If there is an interest in the design of an emittance measuring system an estimate of the relevant emittance parameters should be given

Continued → next Foil



- Pressure in the beam pipe
- Required sealing (O-ring, metallic)
- Required type of flanges (CF, KF,...)
- Allowed maximum insertion length in beam direction
- Distance: Supporting flange – beam axis
- Pressure of cooling water, if needed
- Required free aperture in case a movable device has to be retracted out of the beam
- In case of slit-systems: Required dimensions of the jaws, required stroke, required free aperture in case of open slits, required accuracy of position measurement

Continued → next Foil

- In case of Faraday cups: End cup or movable cup required (compressed air actuator, ...), Broadband coaxial Faraday cup required, required secondary electron suppression (electric or electric and magnetic)
- In case of beam transformers: Isolating gap performed with O-ring or ceramics with metallic sealing, required bandwidth.
- In case of profile grids (harps): Diameter of the wires, length of the wires, spacing, required number of wires, ceramic or PVC – connector required (PVC=standard)